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STALLMAN & POLLOCK LLP . JAN 06 2004
121 Spear Street, Suite 290
San Francisco, CA 94105
(415) 512-1312

TC 1700

In re Patent Application of: John Rosato et al.

Atty Docket No. SCP-6620

Application No.: 09/408,279

Filed: September 29, 1999

For: PROCESS AND SYSTEM FOR RINSING OF SEMICONDUCTOR SUBSTRATES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	41	MINUS	41	0	x \$18 =	\$0
INDEP.	5	MINUS	5	0	x \$86 =	\$0
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS					+ \$290	\$0
TOTAL						\$0

Small Entity 50% Filing Fee Reduction (if applicable) \$0

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- ☐ No additional fee is required.
- ☒ Applicant(s) hereby petition(s) for a one-month extension of time in which to file the present response and enclose(s) herewith the necessary fee to accompany this petition. A check in the amount of \$110.00 is attached.
- ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. SCP-6620.
A duplicate copy of this sheet is enclosed.

STALLMAN & POLLOCK LLP

Dated: December 18, 2003

By: Kathleen A. Frost
Kathleen A. Frost (Reg. No. 37,326)
Attorneys for Applicant(s)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 December 18, 2003.

Dated: December 18, 2003By: Georgia K. Stith
Georgia K. Stith

09/408,279



-1-

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

John Rosato et al.

Application No.: 09/408,279

Filed: September 29, 1999

For: PROCESS AND SYSTEM FOR
RINSING OF SEMICONDUCTOR
SUBSTRATES

Group Art Unit: 1746

Examiner: M. Kornakov

**RESPONSE TO NOTICE OF NON-
COMPLIANT AMENDMENT**

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Commissioner for Patents
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Alexandria, VA 22313-1450

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with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents,
Washington, DC 20231 on December 18, 2003.

STALLMAN & POLLOCK LLP

Dated: 12/18/2003

By: Georgia K. Stith

Georgia K. Stith

Sir:

In response to the Notice of Non-Complaint Amendment of October 27, 2003, Applicant submits a corrected "Listing of Claims" section to replace the section filed with the Amendment dated October 8, 2003:

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

12/29/2003 JDBALIAN 00000029 09408279

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